				· · · · · · · · · · · · · · · · · · ·				1	
OTES CONTINUED: SCRIBE, ENGRAVE, LASER MARK OR MECHAI STAMP (NO DYES OR INKS) A UNIQUE THREEI NUMBER & REVISION NUMBER ON EACH PAR NUMBERS START AT 001 FOR THE FIRST ARTICL PROCEED CONSECUTIVELY. BAG AND TAG F THEIR DRAWING PART NUMBER, REVISION, V, "TYPE" (IF APPLICABLE), AND QUANTITY. IF PA	E DIGIT SERIAL NRT. SERIAL ZLE AND PARTS WITH VARIANT OR ARTS ARE					ev. date 1 20 JUN 2011 	DCN # E1100335 - -	DRAWING TR - - -	REE #
TOO SMALL TO SCRIBË, BAGGING AND TAG ALONE IS SUFFICIENT. EXAMPLE (PART): 001-v1 EXAMPLE (TAG): DXXXXXX-VY, TYPE-XX, QT									
 MACHINE ALL SURFACES TO REMOVE OXIE USE OF ABRASIVE REMOVAL TECHNIQUES I REFER TO LIGO-E0900364 ALL PARTS SHALL BE MANUFACTURED IN A 	S IS NOT ALLOWED.								
LIGO SPECIFICATION E0900364. 8. ALL MATERIAL IS TO BE VIRGIN MATERIAL (i.e. PLUGS OR RECYCLED MATERIAL). NO REP/ APPROVED IN ADVANCE, AND IN WRITING REFER TO LIGO-E0900364.	PAIRS SHALL BE MADE UNLESS								
	.25	← 4X Ø.129 THRU			.594				
		¥				<mark>-∲- ∲-</mark>]-			
		.594					.25		
		I							
				10.00					
				(.375 - 16 x 10 Lg	.)				
				1 95412A652	THREADED STUD .375-16 X 10. M	MASTER	18-8 SSTL 1		1
				1 95412A652 ITEM NO. PART NUMBER	THREADED STUD .375-16 X 10, MG DESCRIPTION	CMASTER	18-8 SSTL 1 MATERIAL REC	Q SPARE	1
			-	ITEM NO. PART NUMBER	DESCRIPTION PARTS LIS	г	MATERIAL REC		
		DIMENSIONS AR TO FRANCES:	NOTES AND TOLERANCES: (U RE IN 2. REMOVE ALL SHARP 2. REMOVE ALL SHARP	ITEM NO. PART NUMBER NLESS OTHERWISE SPECIFIED PER ASME Y14,5-1994. DOGES, 005-015, FOR MACHINED PARTS. ROUND ALL EDGES PO SUBER HERME PARTS.	DESCRIPTION PARTS LIS CALIFORNIA INSTITUTE OF TECHNOLOGY MASSACHUSETTS INSTITUTE OF TECHNOLOGY	T Part Name Stud, Threaded 1	MATERIAL REC		Baffl
		DIMENSIONS AR TOLERANCES: .XX ± .03 .XXX ± .010 ANGULAR± 0.5 ⁴	NOTES AND TOLERANCES: (U I. INTERPET DRAWING 2. RE IN 3. DO NOT SCALE FROM 4. ALL MACHINING FLUI SULFUR, SULCONE, AND MATEDIAL	ITEM NO. PART NUMBER	DESCRIPTION PARTS LIS LIGO CALIFORNIA INSTITUTE OF TECHNOLOGY MASSACHUSETTS INSTITUTE OF TECHNOLOGY SYSTEM ADVANCED LIGO SUB-SYSTEM ADVANCED LIGO	г	MATERIAL REC 10in Lg., Lock, AR		

D1101245_Stud, threaded 10in Lg., Lock, Arm Cavity Baffle, PART PDM REV: X-000, DRAWING PDM REV: X-001

